

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants: Date: May 20, 2009
Haight et al. Group Art Unit: 1793
Serial No.: 09/933,461 Examiner: Geoffrey S. Evans
Filed: August 20, 2001 Docket No.: YOR919980510US2
For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED 2/24/2009

REMARKS

Enclosed herewith is a Terminal Disclaimer over US 6,333,485. In view thereof
all claims should be allowable.

Please charge any fee necessary to enter this paper and any previous paper to
deposit account 09-0468.

Respectfully submitted,

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